

<b>Notice of References Cited</b>	Application/Control No. 10/664,387		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Albert H. Cutler		Art Unit 2622	Page 1 of 1

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*	B	US-2003/0013484	01-2003	Nishimura et al.	455/556
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